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For: SUPERCRITICAL COMPOSITIONS FOR REMOVAL OF ORGANIC MATERIAL AND METHODS OF

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Amendments to the Claims

This listing of claims replaces all prior versions, and listings, of claims in the aboveidentified application:

1-19. (Canceled)

- 20. (Currently Amended) A The composition of claim 19 comprising sulfur trioxide (SO₂) in a supercritical state, wherein the composition further comprises at least one oxidizer selected from the group consisting of sulfur dioxide (SO₂), nitrous oxide (N₂O), NO, NO₂, ozone (O₃), hydrogen peroxide (H₂O₂), F₂, Cl₂, Br₂, and oxygen (O₂), and wherein the composition is an organic material removal composition.
- 21. (Previously Presented) The composition of claim 20, wherein the at least one oxidizer is in a supercritical state.

22-24. (Canceled)

- 25. (Previously Presented) A composition comprising sulfur trioxide (SO₃) in a supercritical state and an oxidizer, wherein the composition is an organic material removal composition.
- 26. (Canceled)
- 27. (Previously Presented) A composition comprising:
- a first component selected from the group consisting of carbon dioxide (CO₂), ammonia (NH₃), H₂O, nitrous oxide (N₂O), carbon monoxide (CO), nitrogen (N₂), helium (He), neon (Ne), argon (Ar), krypton (Kr), and xenon (Xe);

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a second component selected from the group consisting of sulfur dioxide (SO₂), nitrous oxide (N₂O), NO, NO₂, ozone (O₃), hydrogen peroxide (H₂O₂), F₂, Cl₂, Br₂, and oxygen (O₂); and sulfur trioxide (SO₃) in a supercritical state, wherein the composition is an organic material removal composition.

- 28. (Previously Presented) The composition of claim 27, wherein the first component is carbon dioxide.
- 29. (Previously Presented) The composition of claim 27, wherein a ratio of the first component to the total of the second component plus sulfur trioxide is about 1:100 by volume to about 100:1 by volume.
- 30. (Canceled)
- 31. (Previously Presented) The composition of claim 28, wherein a ratio of carbon dioxide:sulfur trioxide is about 10:1 by volume to about 1:1 by volume.
- 32. (Previously Presented) The composition of claim 27, wherein the first component is in a supercritical state.
- 33-42. (Canceled)
- 43. (Previously Presented) The composition of claim 27, wherein the second component is in a supercritical state.
- 44. (Previously Presented) The composition of claim 27, wherein the first component and the second component are both in supercritical states.

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45. (Canceled)

- 46. (Currently Amended) The composition of claim 20 19 further comprising a component selected from the group consisting of hydrogen chloride, hydrogen bromide, hydrogen fluoride, ammonium fluoride, tetramethylammonium fluoride, tetramethylammonium hydroxide, beta-diketones, fluorinated-diketones, organic acids, and combinations thereof.
- 47. (Previously Presented) The composition of claim 25 further comprising a component selected from the group consisting of hydrogen chloride, hydrogen bromide, hydrogen fluoride, ammonium fluoride, tetramethylammonium fluoride, tetramethylammonium hydroxide, beta-diketones, fluorinated-diketones, organic acids, and combinations thereof.
- 48. (Previously Presented) The composition of claim 27 further comprising a component selected from the group consisting of hydrogen chloride, hydrogen bromide, hydrogen fluoride, ammonium fluoride, tetramethylammonium fluoride, tetramethylammonium hydroxide, beta-diketones, fluorinated-diketones, organic acids, and combinations thereof.

49. (Canceled)

- 50. (Previously Presented) A composition comprising sulfur trioxide (SO₃) in a supercritical state and an oxidizer, wherein the composition is a composition for removing exposed organic material from an object.
- 51. (Previously Presented) A composition comprising:
- a first component selected from the group consisting of carbon dioxide (CO_2) , ammonia (NH_3) , H_2O , nitrous oxide (N_2O) , carbon monoxide (CO), nitrogen (N_2) , helium (He), neon (Ne), argon (Ar), krypton (Kr), and xenon (Xe);

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a second component selected from the group consisting of sulfur dioxide (SO₂), nitrous oxide (N₂O), NO, NO₂, ozone (O₃), hydrogen peroxide (H₂O₂), F₂, Cl₂, Br₂, and oxygen (O₂); and sulfur trioxide (SO₃) in a supercritical state, wherein the composition is a composition for removing exposed organic material from an object.

52. (Canceled)

- 53. (Previously Presented) A composition comprising sulfur trioxide (SO₃) in a supercritical state and an oxidizer, wherein the composition is a composition for removing exposed organic material from a substrate assembly.
- 54. (Previously Presented) A composition comprising:

a first component selected from the group consisting of carbon dioxide (CO₂), ammonia (NH₃), H₂O, nitrous oxide (N₂O), carbon monoxide (CO), nitrogen (N₂), helium (He), neon (Ne), argon (Ar), krypton (Kr), and xenon (Xe);

a second component selected from the group consisting of sulfur dioxide (SO₂), nitrous oxide (N₂O), NO, NO₂, ozone (O₃), hydrogen peroxide (H₂O₂), F₂, Cl₂, Br₂, and oxygen (O₂); and sulfur trioxide (SO₃) in a supercritical state, wherein the composition is a composition for removing exposed organic material from a substrate assembly.

- 55. (New) The composition of claim 20 further comprising a substrate assembly in contact with the organic material removal composition.
- 56. (New) The composition of claim 25 further comprising a substrate assembly in contact with the organic material removal composition.

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57. (New) The composition of claim 27 further comprising a substrate assembly in contact with the organic material removal composition.

- 58. (New) The composition of claim 50 further comprising a substrate assembly in contact with the composition for removing exposed organic material from an object.
- 59. (New) The composition of claim 51 further comprising a substrate assembly in contact with the composition for removing exposed organic material from an object.